

# VESPA

## Vaso per Esperimenti Su Plasmi ed Altro

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December 25, 2019

## 1 Aims

Study the *Vespa* experimental apparatus, and in particular:

- Model the vacuum system behavior, finding the characteristic parameters;
- Obtain the current-voltage and the current-temperature characteristics curves of the filament;
- Draw the voltage-current characteristics curves of the gas discharge, enhancing their behavior as varying pressure;
- Find the Paschen curve, both in DC and RF condition;
- Measurement of plasma parameters through a Langmuir probe, both in stationary conditions and via ionic-sonic wave propagation.

## 2 Vacuum system

The vacuum inside the VESPA vessel (a cylindrical vessel, with a length of  $\sim 80\text{cm}$  and a radius of  $\sim 20\text{cm}$ :  $V \sim 0.1\text{m}^3$ ) is obtained and kept thanks to a rotary pump and a turbomolecular pump. The vessel is not perfectly isolated and some small leaks affect the vacuum keeping. To study this phenomena, the vessel has been taken to a low pressure ( $\sim 6 \cdot 10^{-5}\text{mbar}$ ) and all the valves around have been closed. Isolating the chamber from the pumping system one can measure (thanks to a ionization pressure gauge) the pressure in the vessel as function of time. Effects as leaks and degasing contribute to an inflow in the chamber  $F_0(p)$  that in principle could depend on the pressure. Assuming instead  $F_0$  constant, its value can be estimated through a linear fit on the data:  $P = a + b \cdot t$ ,  $F_0 = V \cdot b$ .

Considering the reaction time, the slowness of the ionization gauge in stabilizing and the pressure oscillations, the errors are estimated as 5% on the pressure and a 0.5s error on the time.

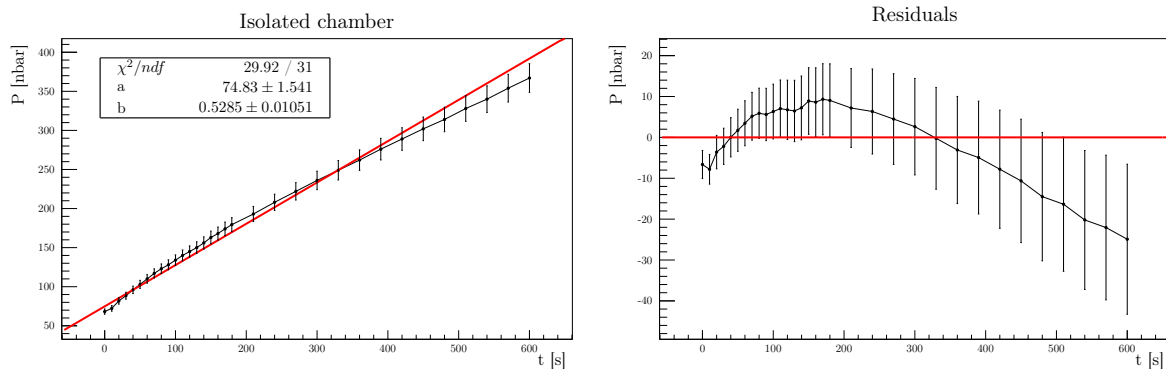


Figure 1: Presure increasing in the chamber

As can be seen from fig 1 there is an evident trend in the residuals, proving that  $F_0$  cannot be assumed constant throughout all the explored range of pressures. A simple way to correct this is to

consider a low pressure regime and a high pressure one: the limit has been put where the trend in the residuals inverts, i.e. around 200nPa.

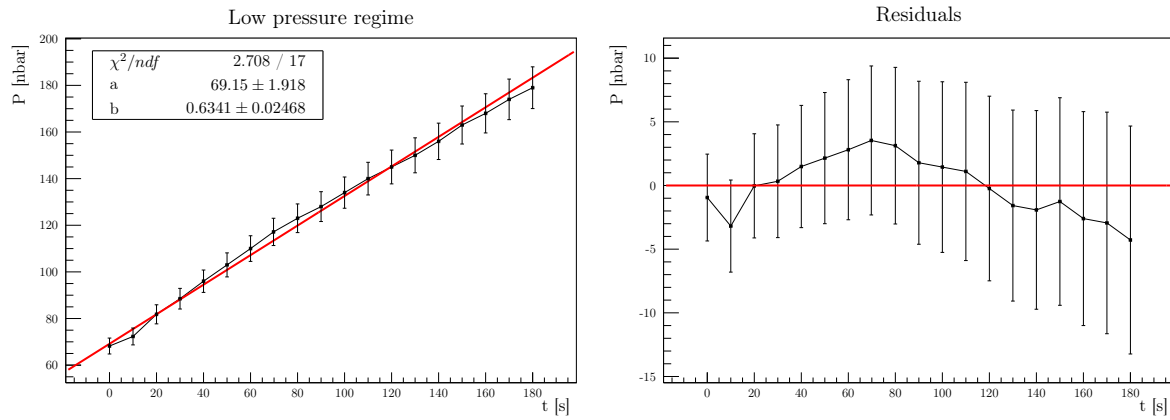


Figure 2: Low pressure regime

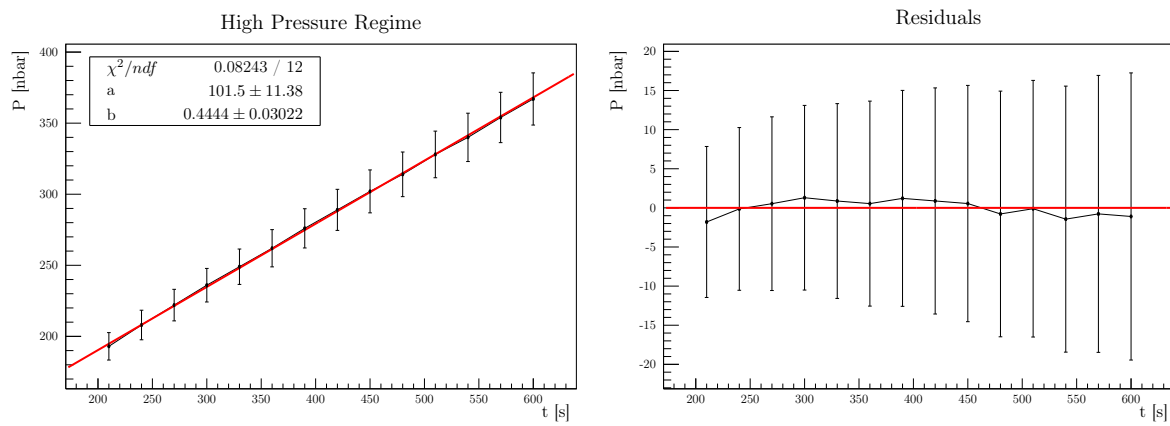


Figure 3: High pressure regime

Secondo me è un po' un casino, un po' tutto stretto. Proporrei invece al posto delle figure 3 e 2 la figura seguente:

### Low and High pressure regimes

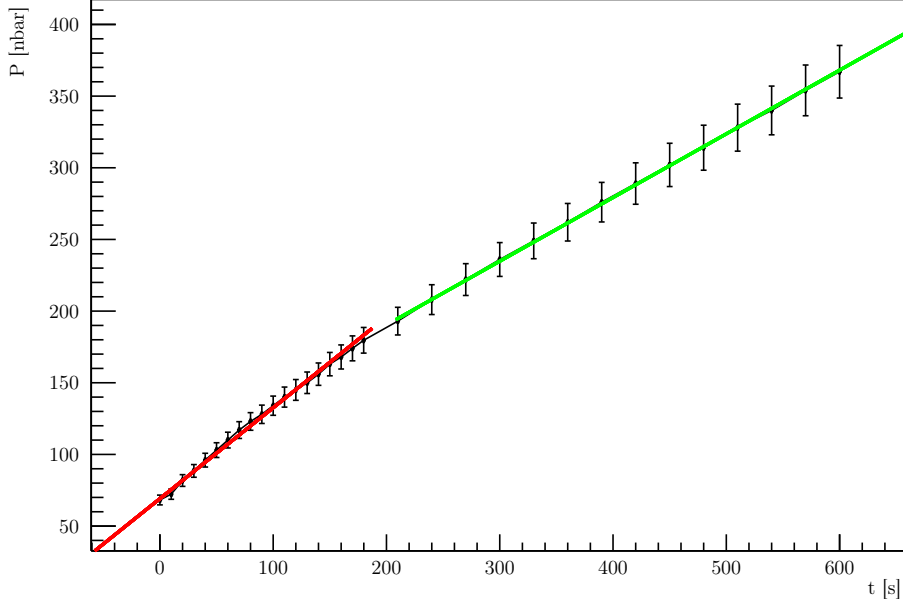


Figure 4: Fits in the two regimes.

REPLY: secondo me no: i residui ci stanno

Splitting the high pressure area and the low pressure area, performing two different fits and assuming a 5% error on the volume, the inflow can be estimated as:

$$F_0^{\text{low}} = (6.4 \pm 0.4) \cdot 10^{-6} \text{Pa m}^3/\text{s}, \quad F_0^{\text{high}} = (4.5 \pm 0.4) \cdot 10^{-6} \text{Pa m}^3/\text{s}$$

Subsequently, the valve has been opened connecting the chamber to the pumping system. An exponential decay of the pressure is expected:  $P(t) = (P_i - P_0) \exp(-t/\tau) + P_0$ , where  $P_i$  is the starting pressure and  $P_0$  the asymptotic pressure.

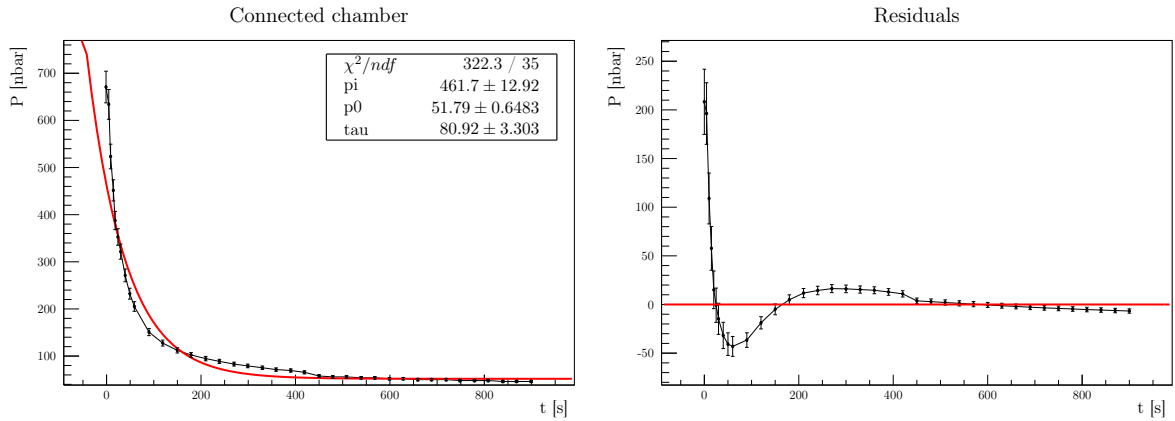


Figure 5: Pressure decreasing in the chamber

As can be seen from fig 5, similarly as what seen before, the results are not acceptable and as before two regimes can be distinguished. For coherence the same limit as before has been used.

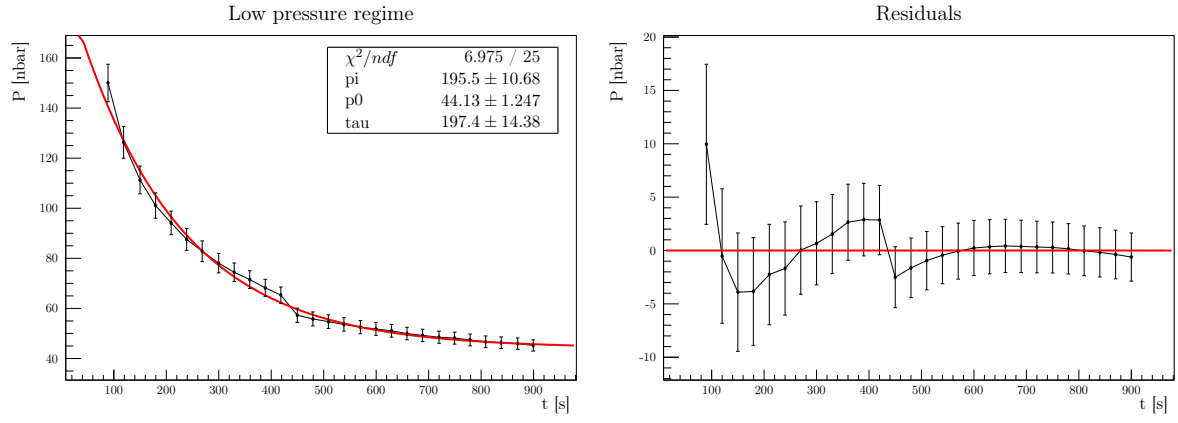


Figure 6: Low pressure regime

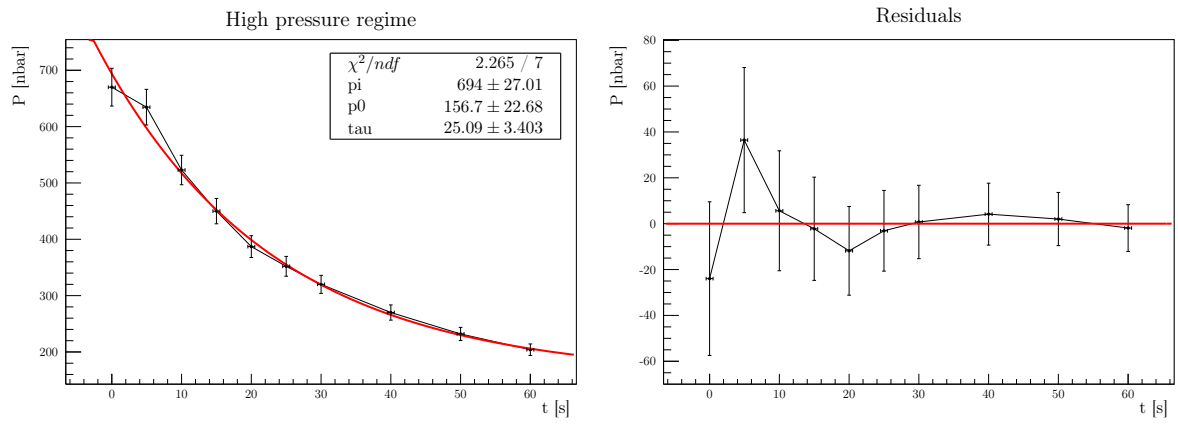


Figure 7: High pressure regime

Facendo un grafico in scala logaritmica, sembra invece che ci siano tre regimi! Vedere figura seguente

### Different regimes in chamber emptying

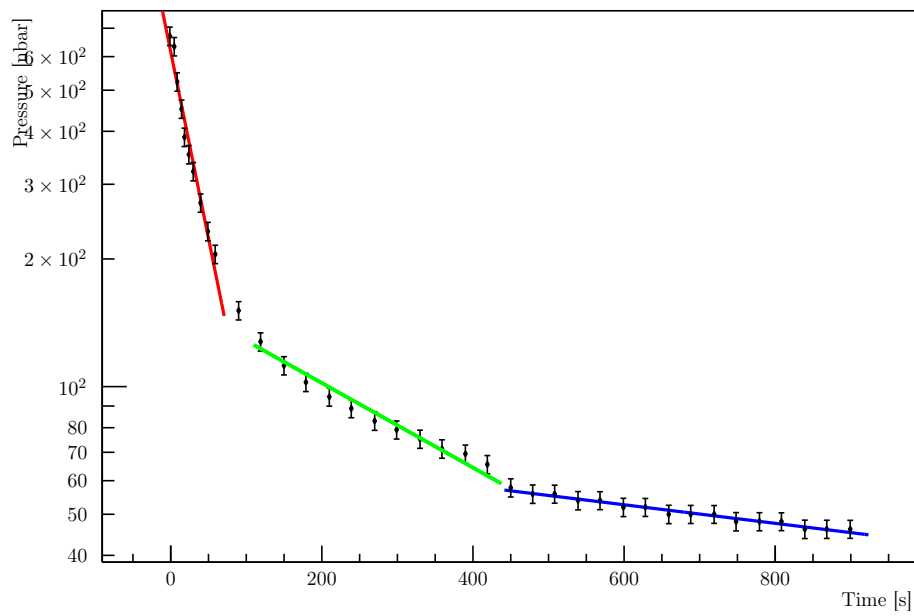


Figure 8: Fits in different regimes.

REPLY: secondo me no: 1) Il regime intermedio non sembra un gran che: c'è forte andamento nei residui. 2) tenendo solo due regimi si riesce a fare meglio il confronto più avanti

Performing two different exponential fits there are still trends in the residuals, but now the result is acceptable. From the values of  $\tau$  and  $P_0$  the effective pumping speed  $S_e$ , the inflow  $F_0$  and, given the nominal value of the pumping speed  $S = 33\text{l/s}$ , the conductance of the chamber-pump connection  $C$  can be estimated.

regime	$S_e = V/\tau$ [l/s]	$F_0 = P_0 \cdot S_e$ [Pa m <sup>3</sup> /s]	$C = 1/(1/S_e - 1/S)$ [l/s]
low pressure	$0.51 \pm 0.04$	$(2.2 \pm 0.2) \cdot 10^{-6}$	$0.52 \pm 0.05$
high pressure	$4.0 \pm 0.6$	$(2 \pm 1) \cdot 10^{-5}$	$4.6 \pm 0.7$

Table 1: Vacuum parameters

In the low pressure regime the two estimates of  $F_0$  are not compatible but still comparable, on the other hand at high pressure the two estimates differ by an order of magnitude. By comparing the nominal value of the pumping speed with  $S_e$  one can deduce that most of the pump potential is wasted by a very low conductance connection.

### 3 Voltage-Current characteristic of the filament

The filament inside the vessel is a tungsten filament with diameter  $2r \sim 0.25\text{mm}$  and length  $L \sim 10\text{cm}$ . Combining Ohm law and emissivity rules, a theoretical characteristic curve can be obtained:

$$V = \frac{A^{10/7} L}{\pi^{13/7} r^{23/7} (2\epsilon\alpha)^{3/7}} \cdot I^{13/7}$$

where  $\epsilon$  is the effective emissivity,  $\alpha$  the StefanBoltzmann constant and  $A$  the resistivity proportional constant, such that the resistivity  $\rho$  can be expressed as function of the temperature  $T$  as

$$\rho(T) = AT^{6/5}$$

Pumping the vessel to a low pressure ( $\sim 2$

missing unit

), the voltage-current characteristic curve of the filament has been measured, producing the following data:

### Voltage-Current characteristic

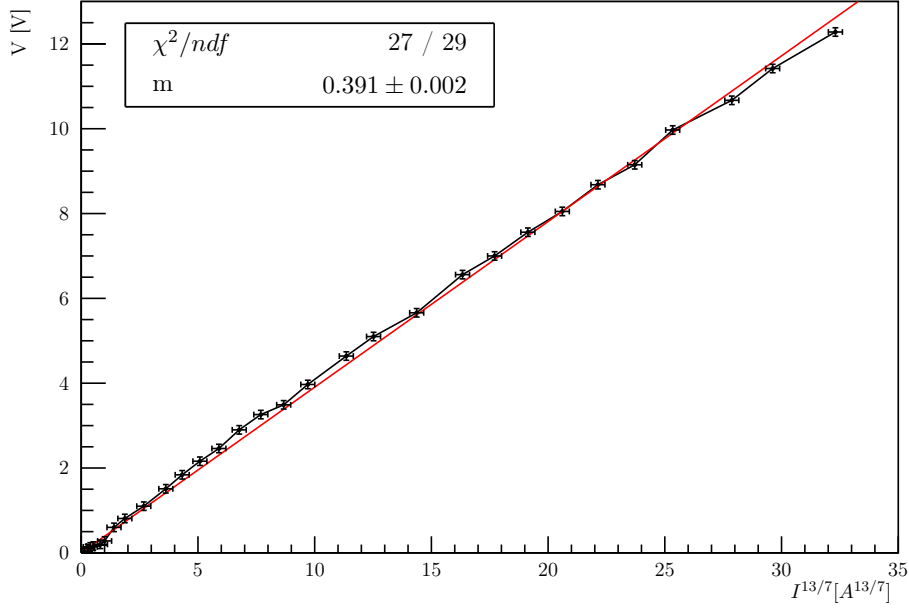


Figure 9: Voltage-Current characteristic for a filament; errors has been chosen as  $0.3A^{13/7}$  and  $0.1V$ , due to the low sensibility of the measure system.

Fitting the data with a  $V \propto I^{13/7}$ , the following parameters are found:

$$V = mI^{13/7} \quad (1)$$

$$m = (0.391 \pm 0.002)V \cdot A^{-13/7} \quad (2)$$

which lead to a value of

$$\epsilon \sim 0.2$$

The  $\chi^2$  confirm the meaningfulness of the fit; moreover, the effective emissivity has a value similar to the typical ones (0.3).

Finally, the estimated filament temperature as a function of the driven current can be found:

$$T = \underbrace{\frac{A^{5/14}}{\pi^{5/7} r^{15/14} (2\epsilon\alpha)^{5/14}}}_k \cdot I^{5/7} \quad \text{with } k \sim 811K \cdot A^{-5/7}$$

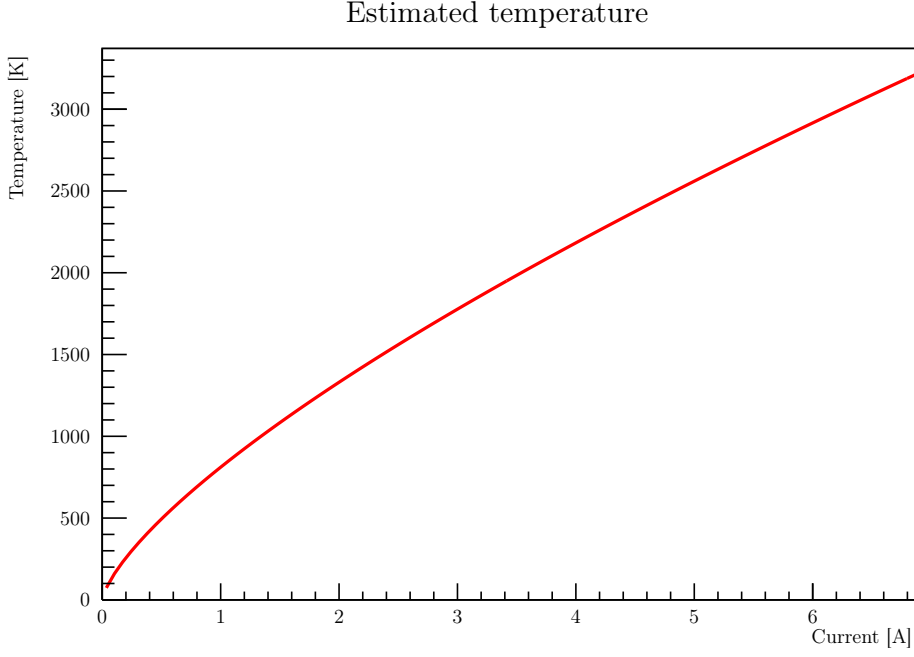


Figure 10: Projection of the filament temperature as function of the current

## 4 V-I characteristics of the discharge & DC Paschen curve

By polarizing the filament with respect to the whole vessel (grounded) a discharge in the plasma can be achieved. By measuring the polarization voltage on the power supply (0.1V estimated error) and the plasma current via the voltage across a resistor  $R_{\text{shunt}} = (1.00 \pm 0.03)\Omega$ , the discharge characteristic curve can be studied. In particular the breakdown is clearly visible.

### 4.1 Varying $I_f$

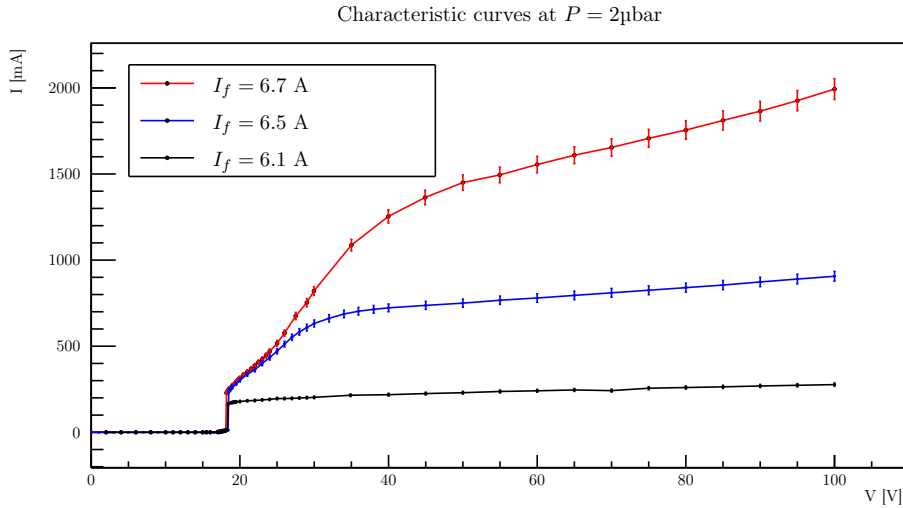


Figure 11: V-I characteristics of the discharge at constant pressure  $P$ , varying the filament current  $I_f$ . The breakdown is clearly visible around  $\sim 18$ V.

As can be seen from fig 11, variations on filament current doesn't affect breakdown voltage, but changes the behavior of the plasma once it is ignited.

The current emitted by the filament into the plasma can be modeled by Richardson law:

$$I = \Sigma A T^2 \exp\left(-\frac{e\Phi}{k_B T}\right)$$

where for our tungsten filament  $A = 7 \cdot 10^5 \text{ A/m}^2 \text{K}^2$ ,  $\Phi = 4.55 \text{ V}$  and  $\Sigma = 2\pi r L \sim 80 \text{ mm}^2$  is the surface area of the filament. By using the previous found relation between the temperature and the filament current  $T = k \cdot I_f^{5/7}$ , and assuming that the plasma current is the whole current emitted by the filament, an expression for the current can be obtained:

$$I = J I_f^{10/7} \exp(-Q I_f^{-5/7}) \quad \text{where:} \quad J = \Sigma A k^2 \sim 3.6 \cdot 10^7 \text{ A}^{-3/7} \quad Q = \frac{e\Phi}{k_B k} \sim 65 \text{ A}^{5/7}$$

Richardson law predicts no dependence of the plasma current on the polarization voltage  $V$ , so a first comparison between the predicted plasma current and the experimental one is to use for the latter the value at  $V = 60 \text{ V}$ : value at which the plasma has been ignited but the electric field is not strong enough to induce a high multiplication of electrons.

$I_f \text{ [A]}$	$I^{\text{exp}} \text{ [A]}$	$I^{\text{Rich}} \text{ [A]}$	$I^{\text{Rich}}/I^{\text{exp}}$
6.1	0.2	8	34
6.5	0.8	20	25
6.7	1.6	30	19

Table 2: Experimental plasma current at  $V = 60 \text{ V}$  and prediction from Richardson law (since the discrepancies between theoretical and experimental values are very high only approximate values are shown).

Continuano a non convincermi questi valori un po' così. Ma se non troviamo nessuna alternativa ok.

Io non ho alternative in mente

As can be seen from tab 2 the prediction and the data differ by a factor  $\sim 25$ , that is almost the same for every value of the filament current, suggesting that the main error is either in the estimate of coefficient  $J$  or in the assumption that the current emitted by the filament is the plasma current. The latter seems more reasonable since the plasma current varies with  $V$  and can be explained by the absorption of electrons by the gas and the creation of space charge.

On the other hand during data acquisition it has been observed that the voltage across the filament  $V_f$  increases with  $V$ , meaning that the resistivity of the filament becomes greater. This means either that the resistivity does not depend only on the temperature of the filament, or that the temperature does not depend only on  $I_f$ .

## 4.2 Varying $P$

By studying instead the V-I characteristics varying the Argon pressure one obtains the results in fig 12. If one ignores the weird behavior of the  $P = 8 \text{ pbar}$  curve at high  $V$ , it is visible that the main influence of the pressure on the curve is the value of the breakdown voltage, effect that can be better understood building the experimental Paschen curve (fig 13): by setting the pressure in the chamber the breakdown voltage is found by slowly increasing the polarization potential until the plasma ignites.

Sono due punti palesemente sbagliati, relettiamoli e basta secondo me



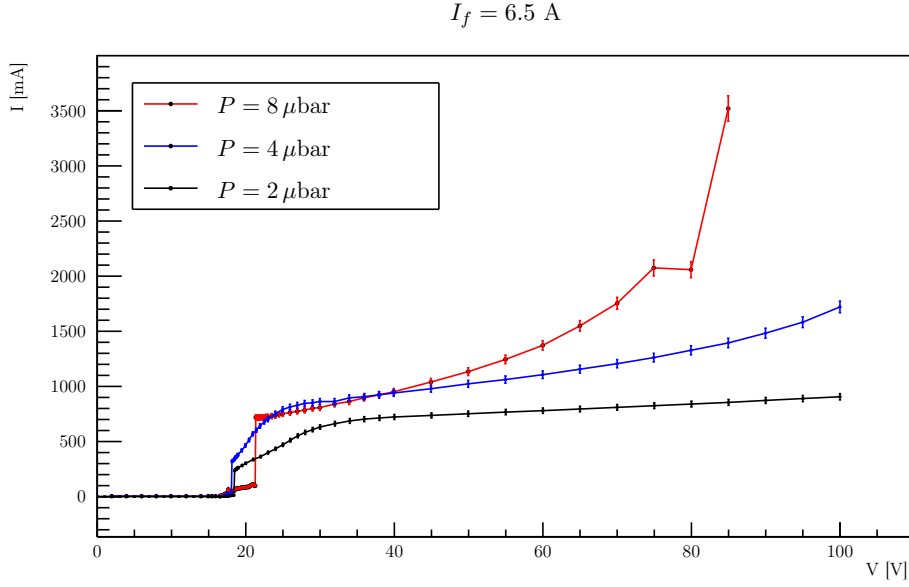


Figure 12: V-I characteristics of the discharge at constant filament current  $I_f$ , varying the pressure  $P$

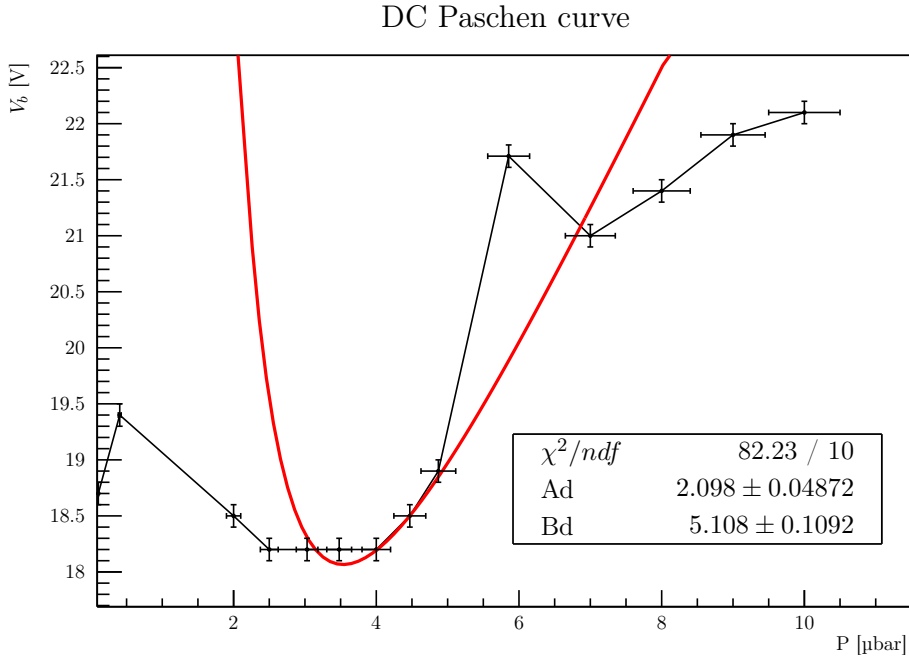


Figure 13: Experimental Paschen curve: breakdown voltage vs  $P$ ; the theoretical Paschen curve is clearly unable to fit the data.

The theoretical formula of the Paschen curve is

$$V_b = \frac{Bpd}{\log(Apd) - C} \quad (pd)_{\min} = \frac{e^{1+C}}{A} \quad (3)$$

where  $d$  is the distance between the electrodes and for Argon  $A = 8.63\text{m}^{-1}\text{Pa}^{-1}$ ,  $B = 132.0\text{Vm}^{-1}\text{Pa}^{-1}$  and  $C = 1.004$ . By keeping  $C$  fixed\* at the theoretical value and varying  $A$  and  $B$  it is possible to perform a fit on the data (fig 13). A way to compare the results of the fit with the theoretical ones is to take consider the ratio  $A/B$ :

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\*Eventual variations of  $C$  can be absorbed into the variation of  $A$ , so keeping  $C$  fixed is not limiting.

$$\left(\frac{A}{B}\right)_{\text{experimental}} = \left(\frac{Ad}{Bd}\right) = (0.41 \pm 0.01)\text{V}^{-1} \quad \left(\frac{A}{B}\right)_{\text{theoretical}} \sim 0.07\text{V}^{-1}$$

As can be seen the experimental results do not agree with the theory both in the sense that the fit with the theoretical curve has a very high  $\chi^2$  and in the sense that the fitting parameters are incompatible with the expected theoretical values.

Another way to see this incompatibility is that even ignoring the fit, from fig 13 it is clear that Paschen's minimum is between 2.5 and 4  $\mu\text{bar}$ , but this would imply that, using the theoretical value for  $A$ ,  $d = \frac{e^{1+C}}{AP_{\min}} \sim 2.4 \text{ m}$ . Result that is rather unphysical considering that the whole chamber is only 0.8 m long.

It can then be deduced that this system does not follow the theoretical Paschen's curve. Anyways, since it would be useful later one can state  $P_{\min} \sim 3 \mu\text{bar}$ .

## 5 Paschen curve in radiofrequency condition

Inside VESPA a magnetic antenna is provided, which allows to ignite the plasma through radiofrequency waves that, coupling with gas electrons, excite them and generate the discharge.

The antenna is powered through a RF generator and a RLC circuit; firstly, the response of the circuit is studied. Keeping fixed the generator power and varying the frequency, through an oscilloscope the peak-to-peak amplitude of the wave downstream the circuit is measured. The result is a typical resonance curve (fig. 14).

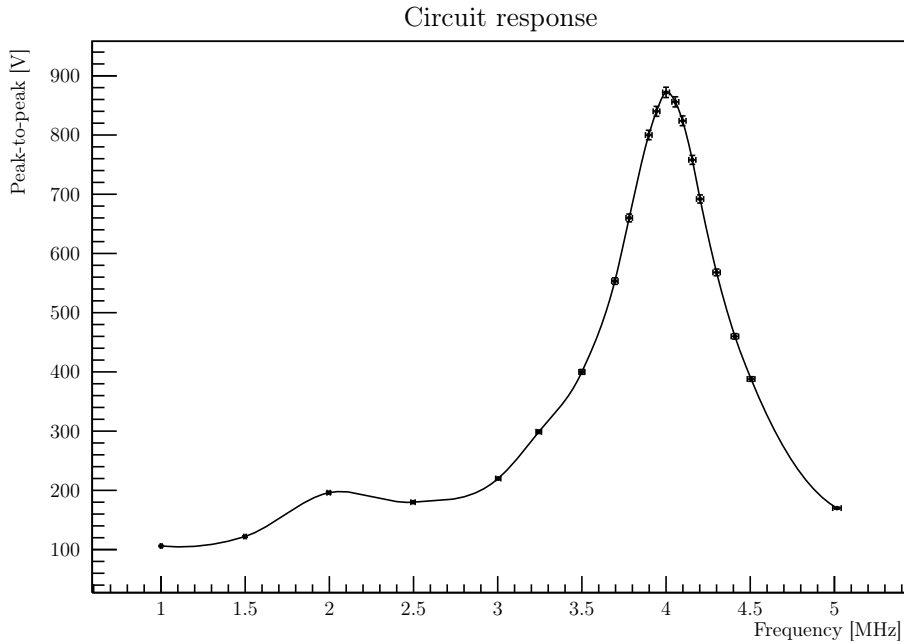


Figure 14: Peak-to-peak amplitude downstream the circuit, varying the wave frequency. From the oscillation in the measurements and the instrumentation sensibility, the errors has been estimated at 5‰ in the frequencies and 1% in voltages.

From the fig. 14 the maximum can be detected: it is around 4MHz. Therefore the operation area is identified in the range 3–4MHz, when the amplitude is high and increasing with the frequency.

Varying the pressure in the vessel, the breakdown voltage trend can be studied. For each pressure, the frequency has been increased until the discharge took place (it's a clearly visible phenomena, so the discrimination has been done visually), and the peak-to-peak voltage in the breakdown point has been measured. The result is the Paschen curve in fig. 15.

## Breakdown voltage - RF discharge

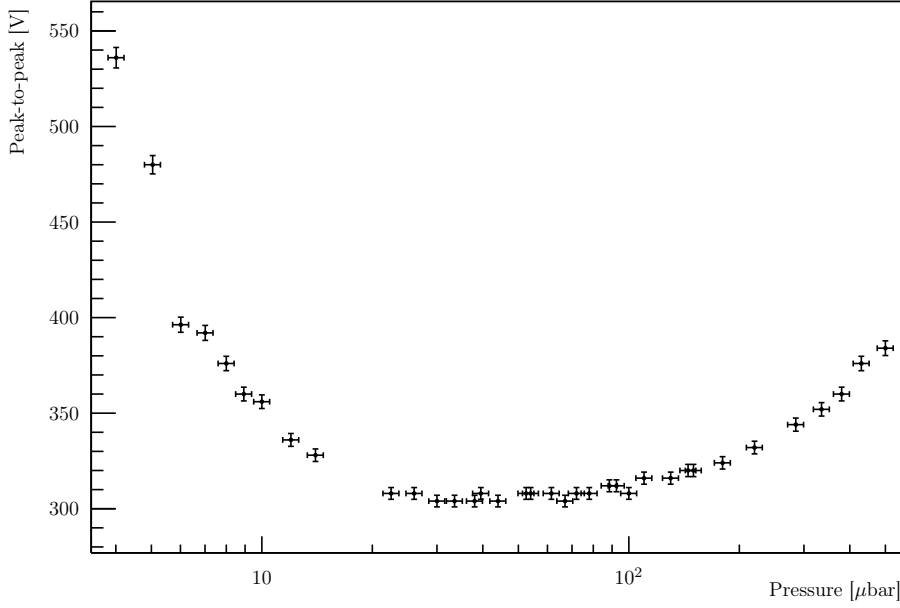


Figure 15: Radiofrequency Paschen curve. From the oscillation in the measurements and the instrumentation sensibility, the errors have been estimated at 5% in the pressures and 1% in voltages.

Si potrebbe provare a fare un fit con la formula di Paschen: i dati sembrano piuttosto belli

As can be seen from the plot, the minimum of the Paschen curve in radiofrequency condition is very wide: the optimal area can be identified in the range:

$$3-7 \cdot 10^{-5} \text{ bar}$$

## 6 Measurement of plasma parameters

Using a Langmuir probe an estimation of plasma parameters such as density, electron temperature and plasma potential can be obtained, throw electric parameters of the filament of which the probe is composed. The electron current from the probe to the plasma is given by the following formula:<sup>†</sup>

$$I = I_{si} (1 + R(V - V_f)) \left( \exp \left( \frac{e(V - V_f)}{kT_e} \right) - 1 \right)$$

where  $I_{si}$  is the *Ion Saturation Current*,  $V_f$  is the *Floating Potential*,  $T_e$  is the *Electronic Temperature* and  $R$  is an additional factor that describes the current-voltage characteristic for  $V \ll V_f$ . Is important to notice that this formula describes experimental data for  $V \lesssim V_f$ , while for higher values of  $V$  additional terms are required. These terms can be obtained throw fitting procedure. An example of electrical voltage-current characteristics is shown in fig. 16 and 17.

Other plasma parameter can be obtained with following formulas:

$$c_s = \left( \frac{eT_e}{m_i} \right)^{1/2}$$

$$n = \frac{2I_{si}}{e c_s A}$$

$$V_p = V_f + \frac{1}{2} \left( \log \left( \frac{m_i}{2\pi m_e} \right) + 1 \right) T_e$$

<sup>†</sup>This formula is a different version of the one derivated in D. Desideri and G.Serianni *Four Parameter data fit for Langmuir probes with nonsaturation of ion current*, Rev. Sci. Instrum., 69 (1998), <https://doi.org/10.1063/1.1148942>

where  $c_s$  is the *ion sound velocity*,  $n$  is the *plasma density*,  $V_p$  is the *plasma potential*,  $m_i$  is the *ion mass*,  $A$  is the probe area and  $e$  is electron charge.

For the characterization of the plasma two Langmuir probes were inserted in the chamber, one in the same side of the filament ("filament side"), and one in the opposite side ("pump side").

## 6.1 Dependence on discharge polarization voltage

In figures 16 and 17 are represented the voltage–current characteristics of the Langmuir probe with respect to the discharge polarization voltage, while pressure and filament current were fixed.

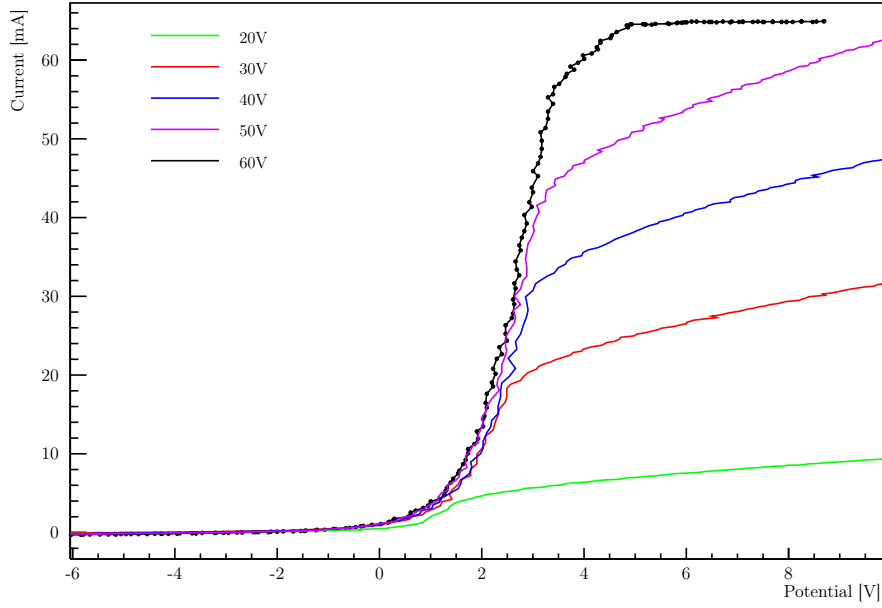


Figure 16: Electrical voltage–current characteristic of the Langmuir probe for a pressure of  $2.84\mu\text{bar}$ , a filament current of  $6.5\text{A}$  and different discharge polarization voltages (as described in legend). In this case the probe is placed in the same side of the filament.

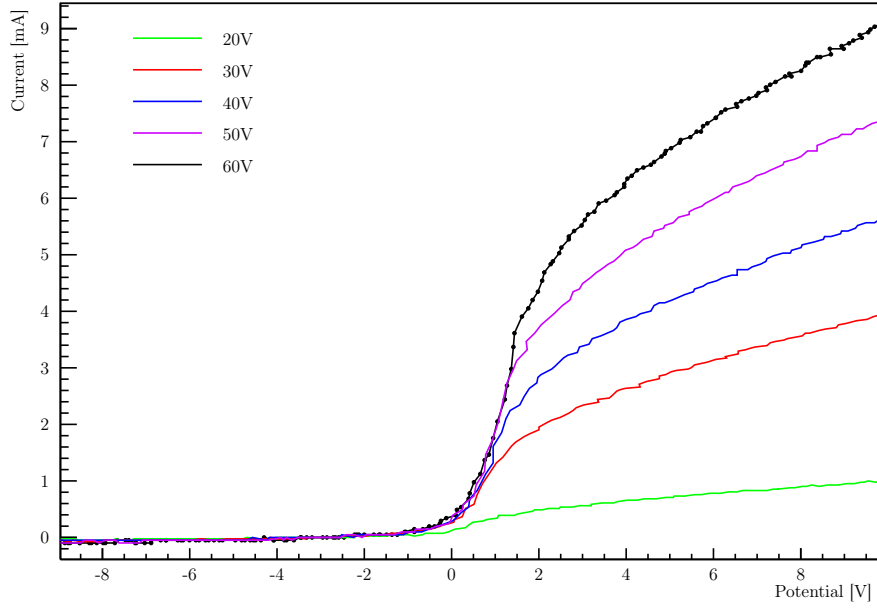


Figure 17: Electrical voltage–current characteristic of the Langmuir probe for a pressure of  $2.84\mu\text{bar}$ , a filament current of  $6.5\text{A}$  and different discharge polarization voltages (as described in legend). In this case the probe is placed in the opposite side to the filament.

Then, plasma parameters, i.e. electron density, electronic temperature and plasma potential, are obtained from the C–V characteristics through the formulas above, and are represented with respect to filament discharge characteristics (discharge voltage and discharge current). Results are represented in graphs 18–23.

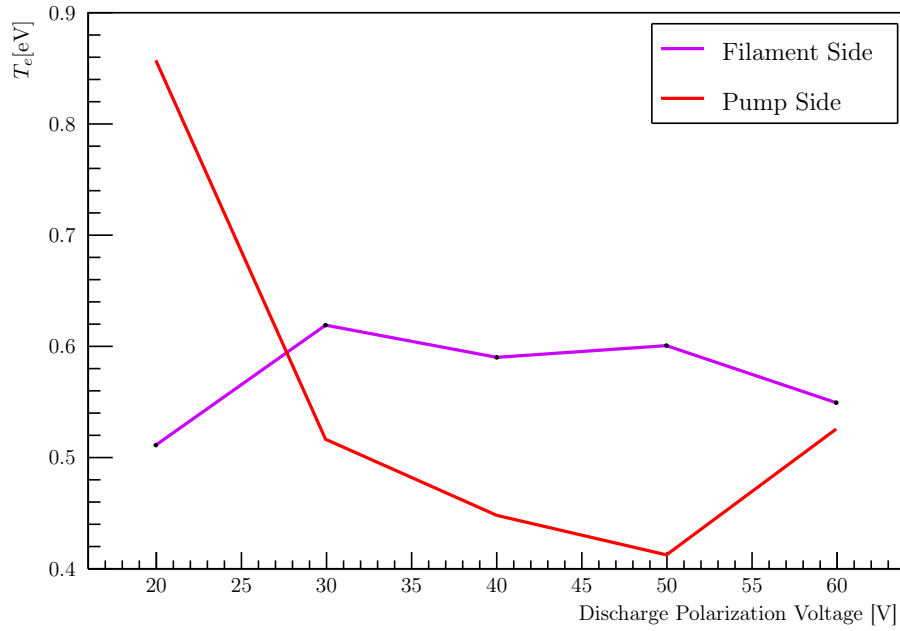


Figure 18: Dependence of electronic temperature on discharge polarization voltage, for a pressure of  $2.84\mu\text{bar}$  and a filament current of  $6.5\text{A}$ . The errors have been estimated at 25% in the temperature and 1V in the voltage.

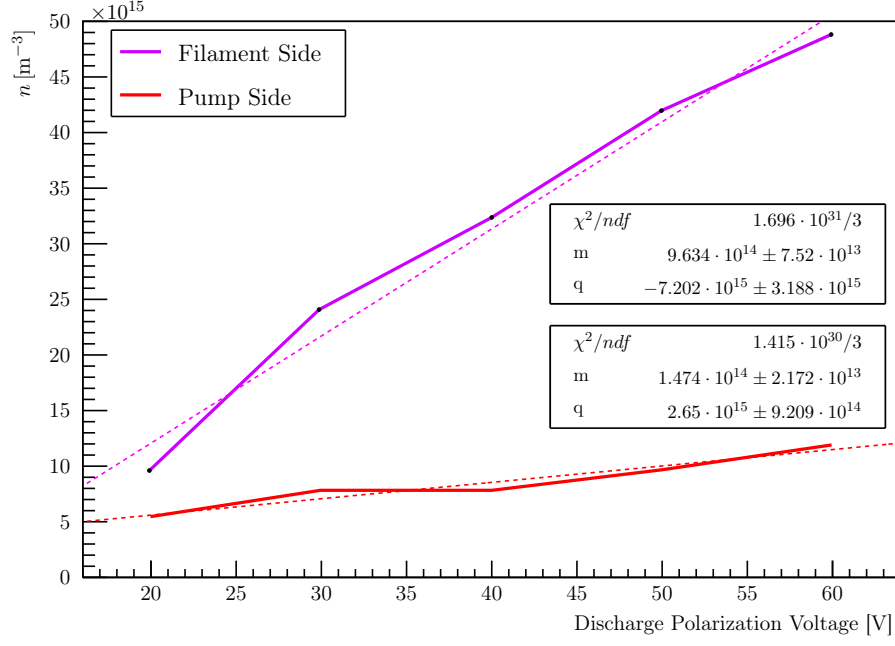


Figure 19: Dependence of density on discharge polarization voltage, for a pressure of  $2.84\mu\text{bar}$  and a filament current of  $6.5\text{A}$ . The errors have been estimated at 20% in the density and 1V in the voltage.

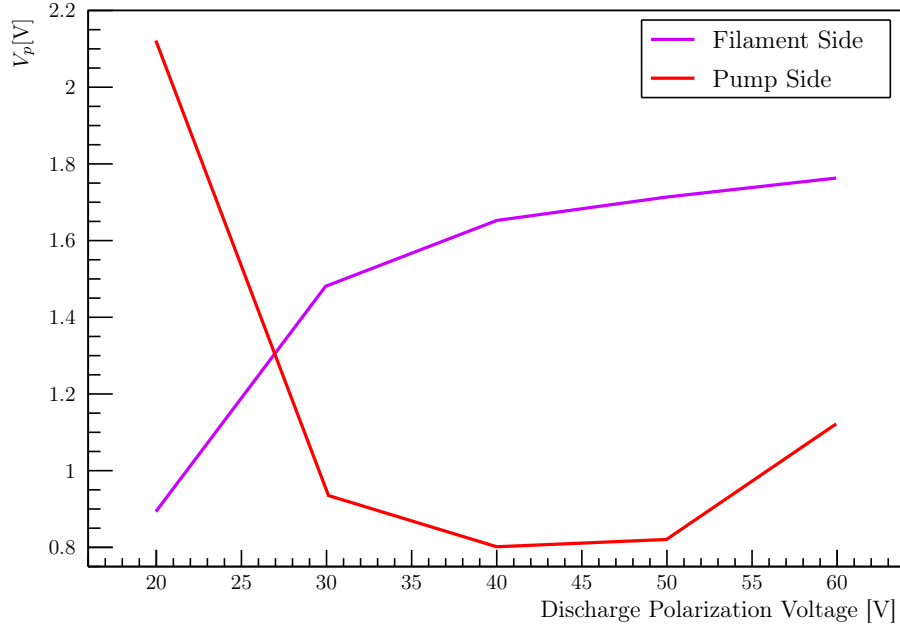


Figure 20: Dependence of plasma potential on discharge polarization voltage, for a pressure of  $2.84\mu\text{bar}$  and a filament current of  $6.5\text{A}$ . The errors have been estimated at 15% in the potential and 1V in the voltage.

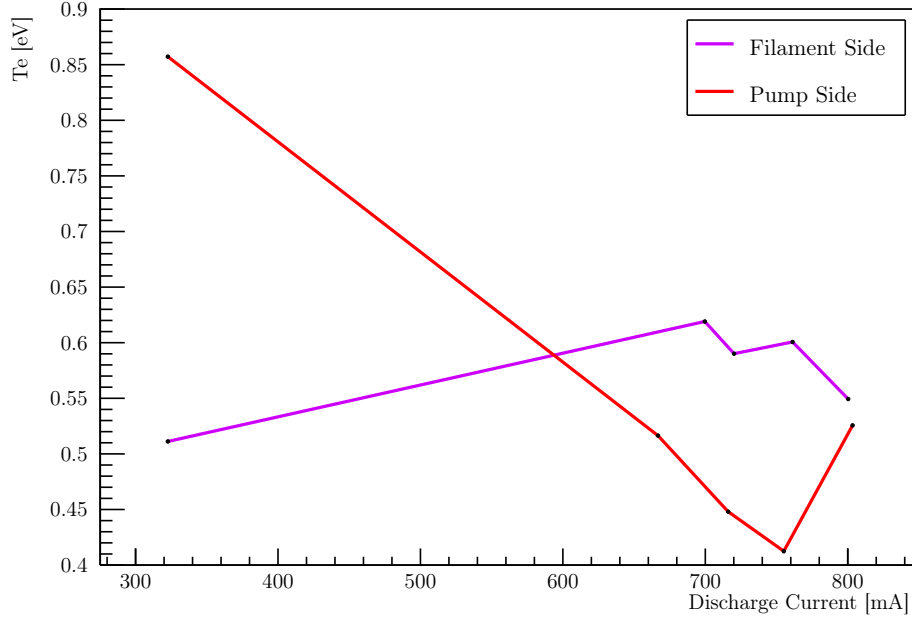


Figure 21: Dependence of electronic temperature on discharge current, for a pressure of  $2.84\mu\text{bar}$  and a filament current of  $6.5\text{A}$ . The errors have been estimated at 25% in the temperature and  $\pm 1\text{mA}$  in the discharge current.

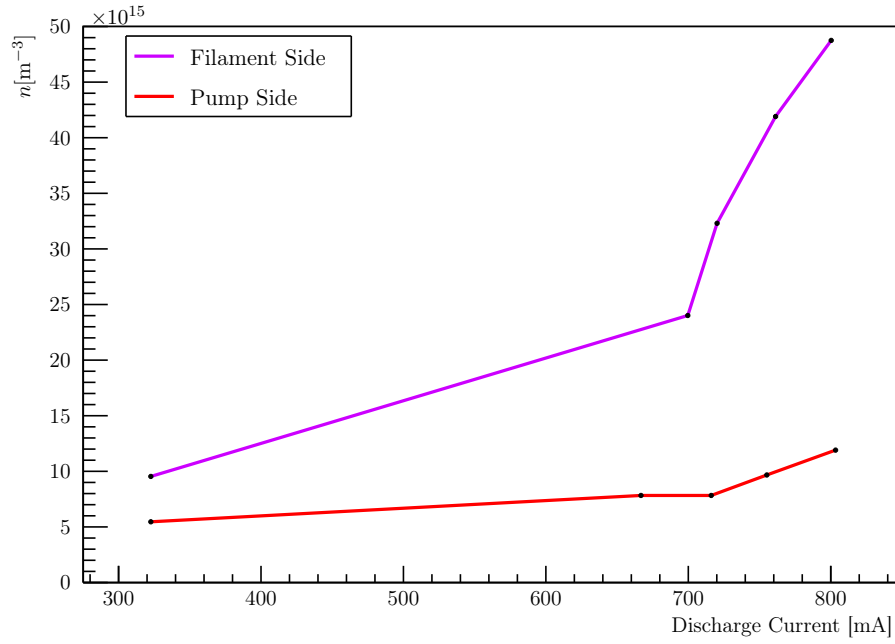


Figure 22: Dependence of density on discharge current, for a pressure of  $2.84\mu\text{bar}$  and a filament current of  $6.5\text{A}$ . The errors have been estimated at 20% in the density and  $\pm 1\text{mA}$  in the discharge current.

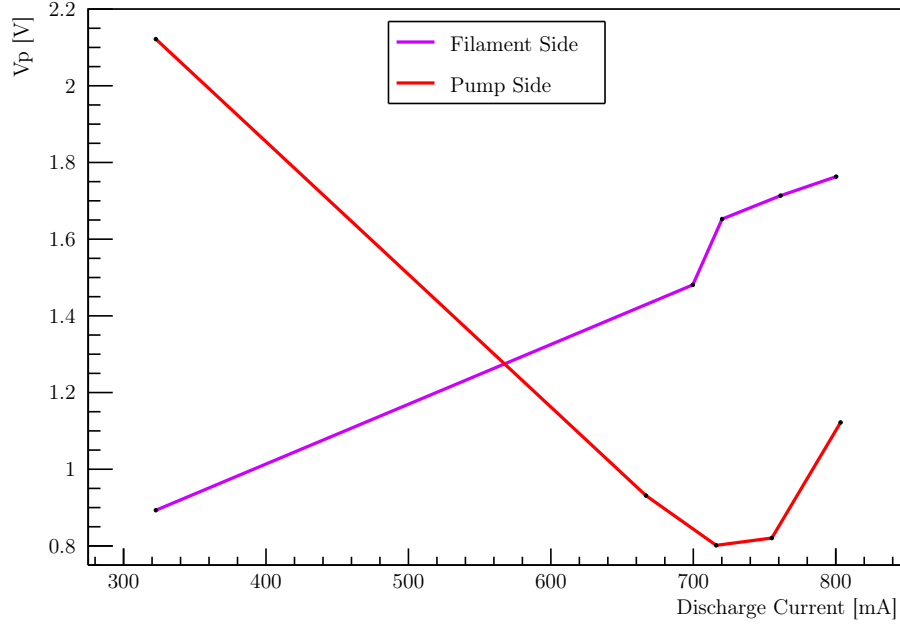


Figure 23: Dependence of plasma potential on discharge current, for a pressure of  $2.84\mu\text{bar}$  and a filament current of  $6.5\text{A}$ . The errors have been estimated at 15% in the potential and  $\pm 1\text{mA}$  in the discharge current.

## 6.2 Dependence on filament current

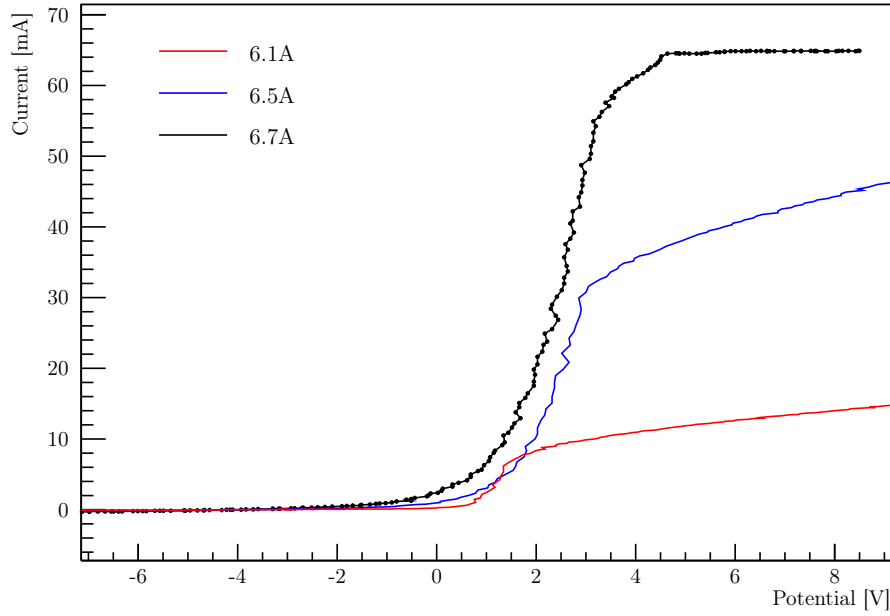


Figure 24: Electrical voltage-current characteristic of the Langmuir probe for a pressure of  $2.84\mu\text{bar}$ , a polarization voltage of  $40\text{V}$  and different filament currents (as described in legend). In this case the probe is placed in the same side of the filament.



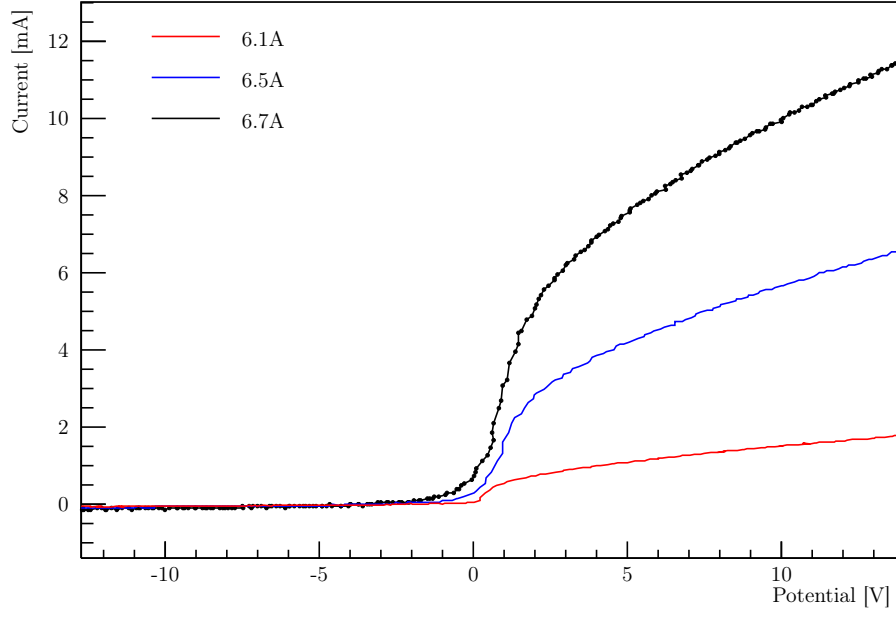


Figure 25: Electrical voltage-current characteristic of the Langmuir probe for a pressure of  $2.84\mu\text{bar}$ , a polarization voltage of 40V and different filament currents (as described in legend). In this case the probe is placed in the opposite side of the filament.

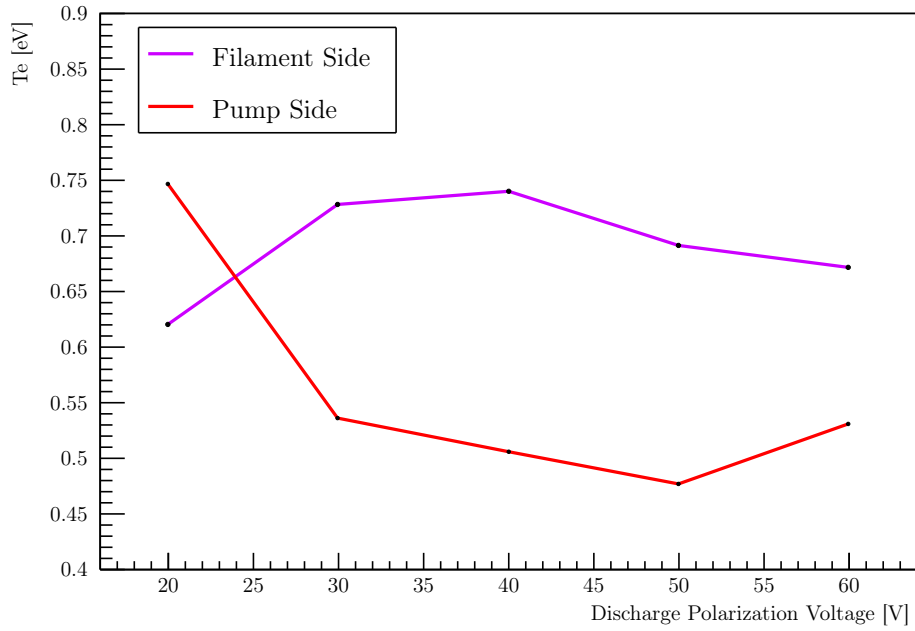


Figure 26: Dependence of electronic temperature on filament current, for a pressure of  $2.84\mu\text{bar}$  and a polarization voltage of 40V. The errors have been estimated at 5% in the temperature and 0.1A in the current.

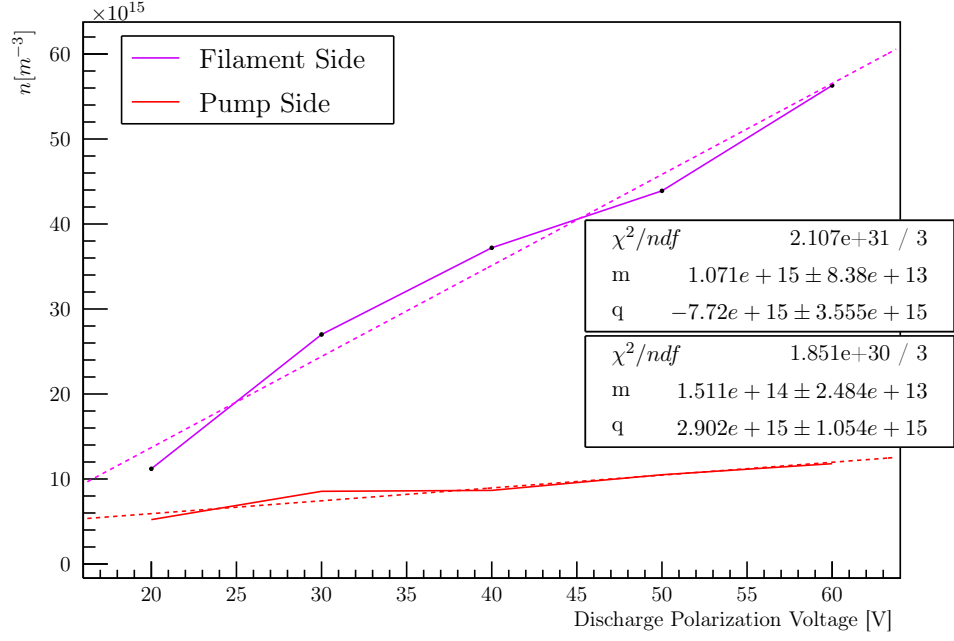


Figure 27: Dependence of plasma potential on filament current, for a pressure of  $2.84\mu\text{bar}$  and a polarization voltage of 40V. The errors have been estimated at 10% in the density and 0.1A in the current.

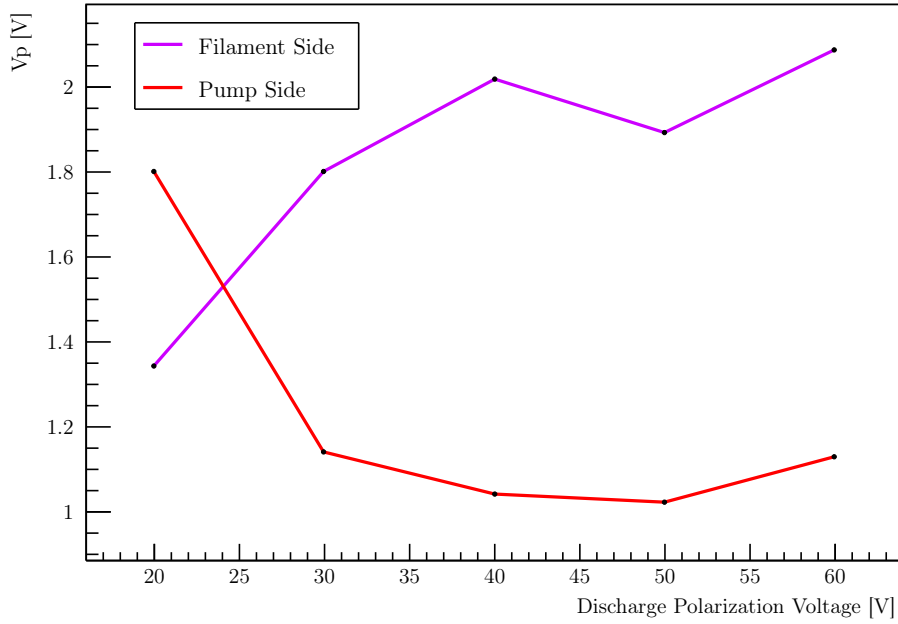


Figure 28: Dependence of density on filament current, for a pressure of  $2.84\mu\text{bar}$  and a polarization voltage of 40V. The errors have been estimated at 5% in the density and 0.1A in the current.

### 6.3 Dependence on pressure

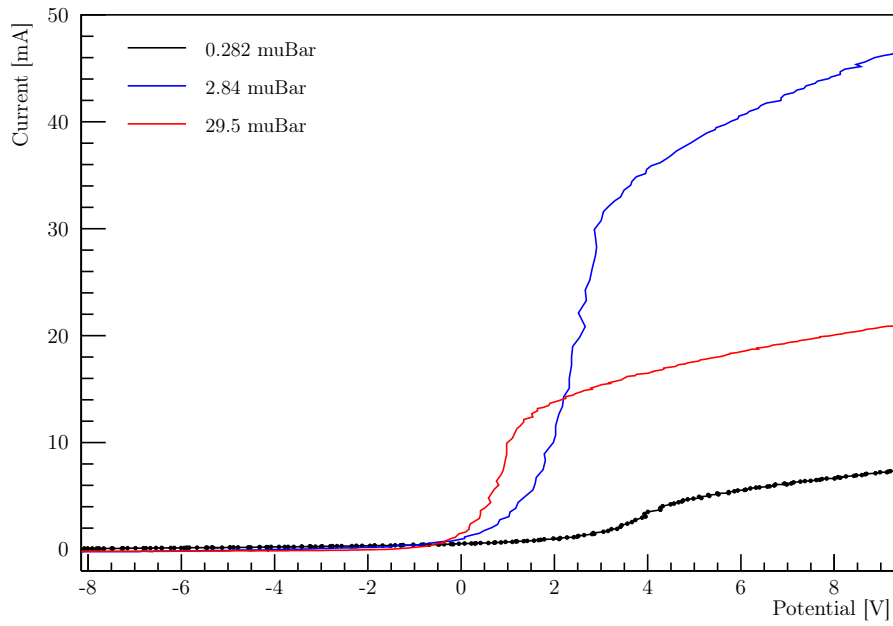


Figure 29: Electrical voltage–current characteristic of the Langmuir probe for a filament current of 6.5A, a polarization voltage of 40V and different pressures (as described in legend). In this case the probe is placed in the same side of the filament.

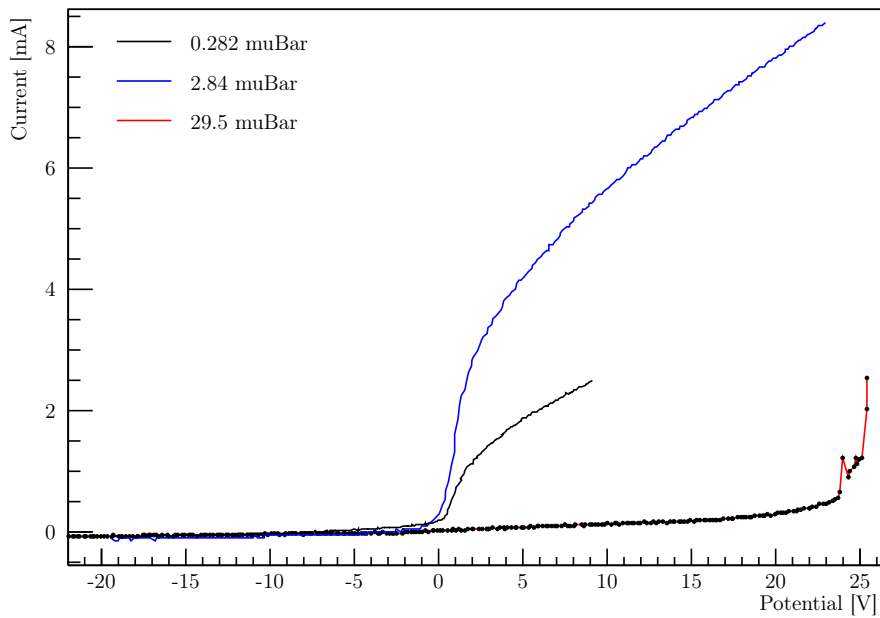


Figure 30: Electrical voltage–current characteristic of the Langmuir probe for a filament current of 6.5A, a polarization voltage of 40V and different pressures (as described in legend). In this case the probe is placed in the opposite side of the filament.

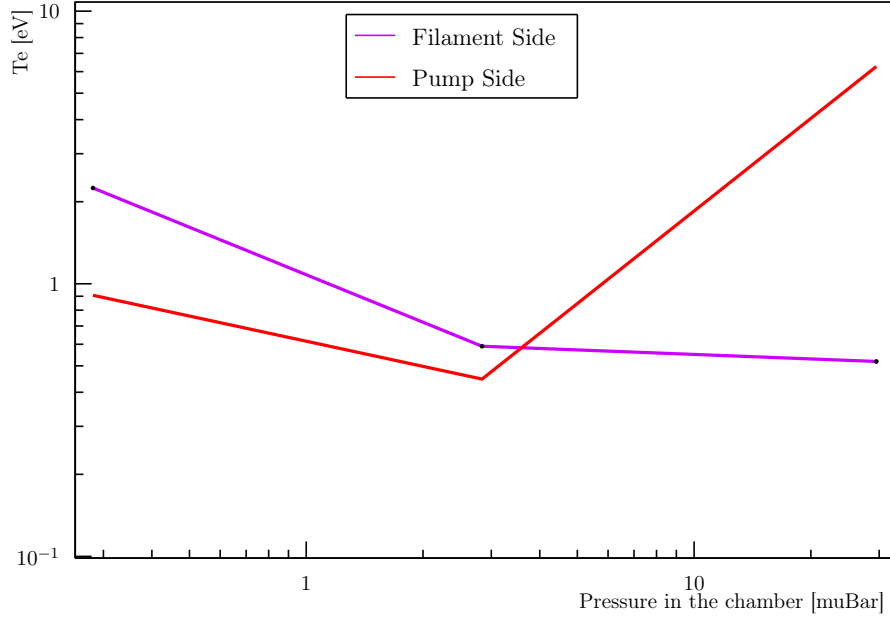


Figure 31: Dependence of electronic temperature on the chamber pressure, for a filament current of 6.5mA and a polarization voltage of 40V. The errors have been estimated at 15% in the temperature and 5% in the pressure. Logarithmic scale has been used for both axis.

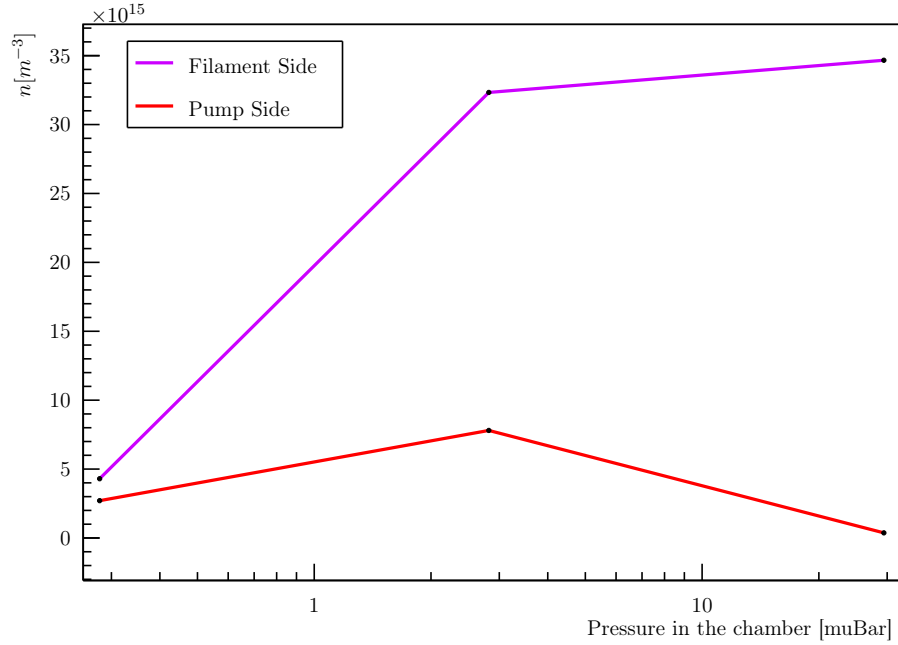


Figure 32: Dependence of density on the chamber pressure, for a filament current of 6.5mA and a polarization voltage of 40V. The errors have been estimated at 20% in the density and 5% in the pressure. Logarithmic scale has been used for X axis.

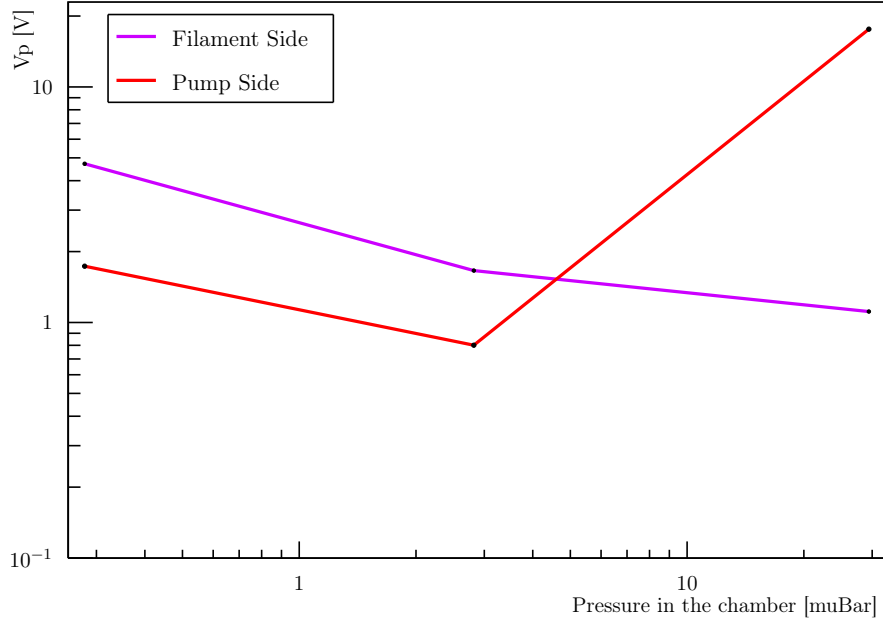


Figure 33: Dependence of plasma potential on the chamber pressure, for a filament current of 6.5mA and a polarization voltage of 40V. The errors have been estimated at 20% in the potential and 5% in the pressure. Logarithmic scale has been used for X axis.

## 7 IonicSonic speed

Through the Langmuir probes, some measurements of the ionic-sonic waves propagation can be done. Igniting the plasma with a filament current of 6.5A, the grid has been polarized with a sinusoidal waves (frequency  $\sim 20.8\text{kHz}$ ,  $V_{\text{peak-peak}} \sim 50\text{V}$ , which also triggers the oscilloscope) and the Langmuir probe has been connected to an oscilloscope. One of the first things noticed is that the plasma distorts the sinusoidal wave: as can be seen from fig. 33, in the output wave the rising time is greater than the falling time.

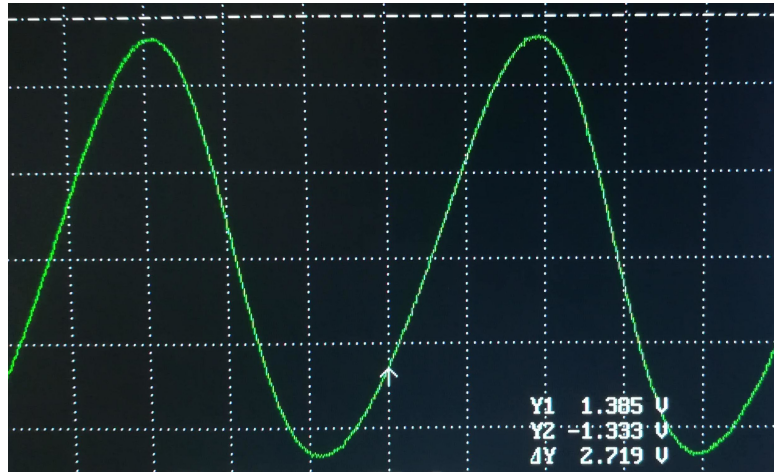


Figure 34: Signal from Langmuir probe: note the distorted sinusoidal wave. Scale: 1 square =  $10\mu\text{s} \times 500\text{mV}$

Moving the probe perpendicularly to the grid, the shift of the maximum and minimum of the detected wave has been measured, and thus the speed estimated.

After various tests, searching for a configuration in which the non linear effects (i.e. the distortion of the sinusoidal wave at various position of the probe) can be neglected, the pressure has been set to

around  $3.26 \cdot 10^{-3}$  mbar and the polarization voltage to 36.0V. The following measurements have been done:

$\Delta x$ [mm]	$\Delta t_{min}$ [ $\mu$ s]	$\Delta t_{max}$ [ $\mu$ s]
$5.0 \pm 0.1$	$2.0 \pm 0.2$	$5.0 \pm 0.2$
$10.0 \pm 0.1$	$5.0 \pm 0.2$	$7.0 \pm 0.2$

Table 3: IonicSonic speed: maximum and minimum shifts

By computing the speed  $c_s$  as  $\Delta x/\Delta t$  in both cases and then taking the average one obtains:

$$\begin{aligned} c_{s,min} &\sim 2.3 \cdot 10^3 \text{ m s}^{-1} \\ c_{s,max} &\sim 1.3 \cdot 10^3 \text{ m s}^{-1} \\ c_s &\sim 1.8 \cdot 10^3 \text{ m s}^{-1} \end{aligned}$$

In a first approximation,

$$c_s = \sqrt{\frac{k_B T_e}{m_i}}$$

where  $m_i$  is the Argon-ion mass ( $m_i \sim 6.63 \cdot 10^{-26}$  kg), which lead to an estimated electron temperature of:

$$T_e \sim 1.3 \text{ eV}$$

Observe that these estimations are very coarse; the used method, the available apparatus and the non-linearity terms doesn't allow a better result.

Compare with predicted one

## 8 IonicSonic decay

Keeping the same system conditions, the amplitude of the wave as function of the probe position has been studied. Moving the probe perpendicularly to the grid and recording the amplitude of the wave, the trend in fig. 34 are found.

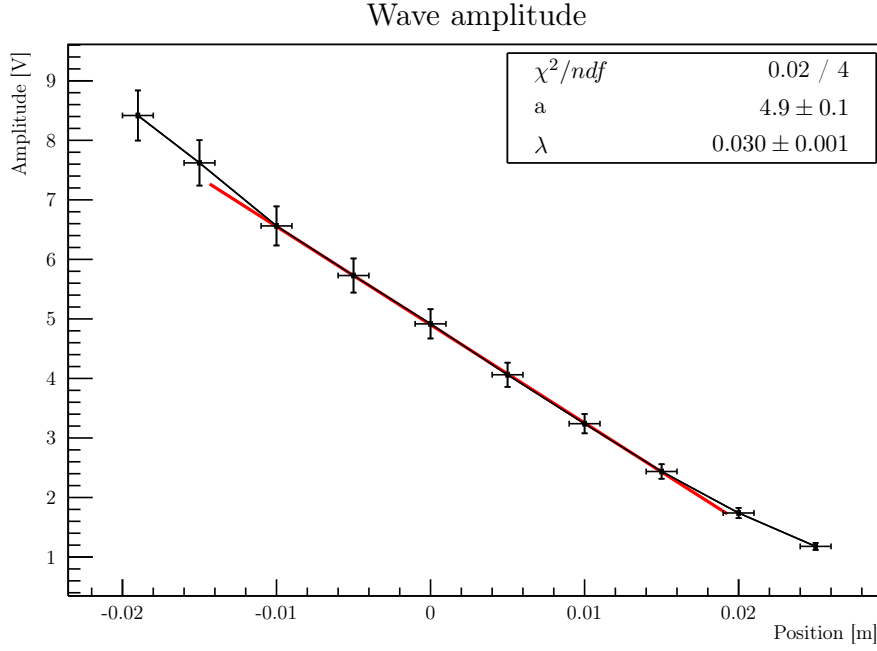


Figure 35: Peak-peak amplitude of the wave as function of the position. The 0 in the x axis has been chosen to be about around the middle of the plot.

From the theory, the amplitude should decay as an exponential. The low range explored doesn't permit a proper exponential fit, thus a first-order approximation around an arbitrary  $d_0$  has been done:

$$Ae^{-d/\lambda} = Ae^{-(d-d_0+d_0)/\lambda} = \underbrace{Ae^{-d_0/\lambda}}_a \left(1 - \frac{d-d_0}{\lambda}\right)$$

Having chosen in the plot the  $x$  axis such that it has the 0 around the middle of the fit range, can be assumed  $x = d - d_0$ . From the fit, the typical length is found:

Non è ben chiaro questo discorso di  $d_0$

$$\lambda = (0.030 \pm 0.001)\text{m}$$

This length can be approximated by:

$$\lambda = \frac{2c_s}{v_{te}n_0\sigma_0}$$

being  $\sigma_0$  the cross section of the collisions of electrons with the neutrals ( $\sigma_0 \sim 2 \cdot 10^{-20}\text{m}^2$ ),  $c_s$  the previous found ionic-sonic speed and  $v_{te}$  the electrons thermal speed ( $v_{te} \sim \sqrt{3k_bT_e/m_e} \sim 8.4 \cdot 10^5\text{m s}^{-1}$ ). This lead to an estimation of the neutral particle density  $n_0$  of:

$$n_0 = 7 \cdot 10^{18}\text{m}^{-3}$$

From the perfect-gas law, we can instead compute (assuming a temperature near to the room one,  $\sim 300\text{K}$ ):

$$p = nk_B T \quad \rightarrow \quad n = \frac{p}{k_B T} \sim 8 \cdot 10^{19}\text{m}^{-3}$$

Dire qualcosa sul fatto che le due stime di  $n_0$  differiscono di un'ordine di grandezza

## 9 Conclusions

With respect to the initial aims:

- By studying the vacuum, the average inflow in the chamber and the pumping speed of the pumping system have been estimated.
- By studying the V-I characteristics of the tungsten filament the relation between the filament current and its temperature has been found.
- The V-I characteristics of the plasma in DC condition has been found and the Paschen curve built: both of them show relevant deviation from the theory.

- Paschen RF results

- Langmuir probes results

- By inducing a sonic wave in the plasma the ionic sonic speed and the wave exponential damping have been estimated.

Other?